



IPW
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Saburo KAMIYA

Group Art Unit: 2851

Application No.: 10/603,743

Examiner: D. Rutledge

Filed: June 26, 2003

Docket No.: 116388

For: EXPOSURE APPARATUS AND EXPOSURE METHOD

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the May 19, 2004 Office Action, the shortened statutory period for reply being extended by the attached Petition for Extension of Time, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.